



IN THE U.S. PATENT AND TRADEMARK OFFICE

July 17, 2008

Applicant(s): Takaomi NAKAYAMA et al

For: TREATING SOLUTION FOR SURFACE TREATMENT OF METAL AND A

METHOD FOR SURFACE TREATMENT

Serial No.: 10/537 329

Group: 1793

Confirmation No.: 8404

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Examiner: Zheng

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Atty. Docket No.: 4626.P0002US

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUPPLEMENTAL RESPONSE

Sir:

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Further to the Response filed July 7, 2008, please amend the above-identified application as follows:

(Please see following pages.)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July _/7 __, 2008.

Terryence F. Chapman